PTO/SB/08 Equivalent

RMATION DISCLOSURE STATEMENT BY APPLICANT

Application No. 09/413,222

Filing Date October 5, 1999

First Named Inventor Mark W. Miles

Art Unit 2873

Examiner Hung X. Dang

Attorney Docket No. IRDM.056CP

(Multiple sheets used when necessary)
SHEET 1 OF 3

			U.S. PATENT	DOCUMENTS	
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
HD	1	5,710,656	01-20-1998	Goossen	
	2	5,703,710	12-30-1997	Brinkman et al.	
	3	5,636,052	06-03-1997	Arney et al.	
	4	5,619,059	04-08-1997	Li et al.	
	5	5,579,149	11-16-1996	Moret et al.	
	6	5,500,761	03-19-1996	Goossen et al.	
	7	5,500,635	03-19-1996	Mott	
	8	5,497,172	03-05-1996	Doherty et al.	
	9	5,459,610	10-17-1995	Bloom	
	10	5,401,983	03-28-1995	Jokerst	
	11	5,381,253	01-10-1995	Sharp et al.	
	12	5,311,360	05-10-1994	Bloom	
	13	5,233,459	08-03-1993	Bozler et al.	
	14	5,231,532	07-27-1993	Magel et al.	
	15	5,168,406	12-01-1992	Nelson	
	16	5,153,771	10-06-1992	Link et al.	
	17	5,124,834	06-23-1992	Cusano et al.	
	18	5,075,796	12-24-1991	Schildkraut et al.	
	19	5,044,736	09-03-1991	Jaskie et al.	
	20	5,022,745	06-11-1991	Zahowski et al.	
	21	4,982,184	01-01-1991	Kirkwood	
	22	4,790,635	12-13-1988	Apsley	
	23	4,748,366	05-31-1988	Taylor	
<del></del> -	24	4,681,403	07-21-1987	TeVelde et al.	
	25	4,663,083	05-05-1987	Marks	
	26	4,531,126	07-23-1985	Sadones	
	27	4,519,676	05-28-1985	TeVelde	
	28	4,445,050	04-24-1984	Marks	
thD.	29	4,403,248	09-06-1983	TeVelde	

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<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T<sup>1</sup> - Place a check mark in this area when an English language Translation is attached.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

	Application No.	09/413,222
	Filing Date	October 5, 1999
	First Named Inventor	Mark W. Miles
	Art Unit	2873
•	Examiner	Hung X. Dang
	Attorney Docket No.	IRDM.056CP

(Multiple sheets used	d when necessary)
SHEET 2	2 OF 3

			U.S. PATENT	DOCUMENTS	
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
#0	30	4,389,096	06-21-1983	Hori et al.	
	31	4,377,324	03-22-1983	Durand et al.	
	32	4,228,437	10-14-1980	Shelton	
	33	4,099,854	07-11-1978	Decker et al.	
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	35	3,813,265	05-28-1974	Marks	
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1	38	3,439,973	04-22-1969	Paul et al.	
44	39	2,534,846	12-19-1950	Ambrose et al.	

			NON PATENT LITERATURE DOCUMENTS	
	niner ials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>1</sup>
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		41	Aratani, et al., "Process and Design Considerations for Surface Micromachined Beams for a Tuneable Interferometer Array in Silicon," IEEE Micro. Workshop, Fort Lauderdale, FL, February 7-10, 1993, pp. 230-235.	·
		42	Aratani, et al., "Surface micromachined tuneable interferometer array," Sensors and Actuators A 43, 1994, pp. 17-23.	
		43	Conner, "P-36: Hybrid Color Display Using Optical Interference Filter Array," SID Digest 1993, pp. 577-580.	
		44	Goossen, et al., "Possible Display Applications of the Silicon Mechanical Anti-Reflection Switch," Society Information Display, 1994.	4
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		46	Gosch, "West Germany Graps the Lead in X-Ray Lithography," Electronics, February 5, 1987, pp.78-80.	
		47	Howard, "Nanometer-Scale Fabrication Techniques," VLSI Electronics: Microstructure Science, Vol. 5, 1982, pp. 145-153 and pp.166-173.	
#	D	48	Jackson, "Classical Electrodynamics," John Wiley & Sons Inc., pp. 568-573.	

Examiner Signature	Ho	Date Considered	11	10	25
*Examiner: Initial if reference in conformance and not consid	considered, whether or not citati ered. Include copy of this form	on is in conformance with MPEP 609. with next communication to applicant.	Draw I	line th	nrough citation if not

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INFORMATION DISCLOSURE

STATEMENT BY APPLICANT

(Multiple sheets used when necessary)
SHEET 3 OF 3

Application No.	09/413,222
Filing Date	October 5, 1999
First Named Inventor	Mark W. Miles
Art Unit	2873
Examiner	Hung X. Dang
Attorney Docket No.	IRDM.056CP

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>1</sup>
HD	49	Jerman et al., "A Miniature Fabry-Perot Interferometer with a Corruggated Silicon Diaphragm Support," Sensors and Actuators A, Vol. 29, pp. 151, 1991.	•
	50	Johnson, "Optical Scanners," Microwave Scanning Antennas, Vol. 1, 1964, pp. 251-261.	•
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	52	Miles, Mark W., "A New Reflective FPD Technology Using Interferometric Modulation," Society for Information Display, 1997 Digest, Session 7.3.	
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	58	Walker et al., "Electron-beam-tunable Interference Filter Special Light Modulator," Optics Letter Vol. 13, No. 5, pp. 345-347, 1988.	•
	59	Winton, John M., "A novel way to capture solar energy," Chemical Week, May 15, 1985, pp. 17-18.	
#D	60	Wu, "Design of a Reflective Color LCD Using Optical Interference Reflectors," ASIA Display 1995, October 16, 1995, pp. 929-931.	

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Examiner Signature Date Considered 11 10 05

<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.